



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kusumoto, et al. Art Unit : 2814
Serial No. : 09/941,367 Examiner : Theresa T. Doan
Filed : August 28, 2001
Title : METHOD FOR PRODUCING INSULATED GATE THIN FILM
SEMICONDUCTOR DEVICE

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO FINAL ACTION OF SEPTEMBER 11, 2003

Please amend the above-identified application as follows:

Amendments to the claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 13 of this paper.